

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1398	SERIAL NO. 09/536,037		
<div style="display: flex; align-items: center;"> <div> <p>LIST OF ART CITED BY APPLICANT</p> <p>(Use several sheets if necessary)</p> </div> </div>				APPLICANT: Li et al.			
				FILING DATE March 27, 2000	GROUP 2822		
U.S. PATENT DOCUMENTS							
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
JmJ	AA	6,121,133	09/19/00	Iyer et al.	438	636	
JmJ	AB	6,632,712 B1	07/11/00	Ang et al.	438	212	
JmJ	AC	5,711,987	07/05/88	Bearinger et al.	427	7	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
JmJ	AJ	TW 471112A TW 47112A	01/01/2002	Taiwan - Abstract			X
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM	Wolf, S., and Tauber, Richard, Silicon Processing for the VLSI Era; Vol. 1; Process Technology; "Silicon: Single Crystal Growth and Wafer Preparation"; pages 1 and 2					
	AN						
EXAMINER		DATE CONSIDERED					
J.M. Thomey		12-08-05					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-1398		SERIAL NO. 09/536,037	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Weimin Li et al.			
					FILING DATE March 27, 2000		GROUP 2822	
U.S. PATENT DOCUMENTS								
Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate	
JMJ	AA	4,592,129	06/1986	Legge, Ronald N.	438	72		
JMJ	AB	6,218,929	04/2001	Foots, David K.	438	638		
JMJ	AC	5,840,610	11/1998	Gilmer et al.	438	301		
JMJ	AD	4,523,214	06/1985	Hirose et al.	257	443		
JMJ	AE	6,432,791	08/2002	Hutter et al.	438	381		
JMJ	AF	6,017,814	01/2000	Tsai et al.	428	209		
JMJ	AG	6,057,217	05/2000	Uwasaw, Kenichi	438	585		
JMJ	AH	6,200,863	03/2001	Xiang et al.	438	286		
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
J. M. Thomas		12-08-05						
<small>* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 809; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								